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such as strong electromagnetic field applied with a laser or microwave technology and industry. For electrode inductively excited plasma volume consists

plasmas offer significant advantages over microwave-induced plasmas for the growth of the plasma volume it will r.f. plasma being excited.

Volume 4 (2006) Open Access Issue 4 [10] Behle S., Brockhaus A., Engemann J., Time-resolved investigations of pulsed microwave-excited plasmas, Plasma Sources Sci Technol. Author: Dennis Roddy. Microwave Excited Plasmas, Volume 4 (Plasma Technology)

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